	Application No.	Applicant(s)		
Notice of Allowability	10/552,497	HANSEN ET AL.		
Notice of Allowability	Examiner	Art Unit		
	Binh X. Tran	1792		
— The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS Is herewith (or previously mailed), a Notice of Allowance (PTOL-8t NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATE of the Office or upon petition by the applicant. See 37 CFR 1.31	S (OR REMAINS) CLOSED in i) or other appropriate common RIGHTS. This application is s	this application. If not included inication will be mailed in due co	urse. THIS	
 This communication is responsive to <u>09-29-2009</u>. 				
2. The allowed claim(s) is/are 1,2,4,7-13 and 16-21.				
	ve been received. ve been received in Applicatio	n No	n from the	
International Bureau (PCT Rule 17.2(a)).	ocuments have been received	in this national stage application	ii iioiii uie	
* Certified copies not received:				
Applicant has THREE MONTHS FROM THE "MAILING DATE noted below. Failure to timely comply will result in ABANDON THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		a reply complying with the requi	rements	
 A SUBSTITUTE OATH OR DECLARATION must be submined in Appendix Patent Application (PTO-152) which gire 			FICE OF	
5. CORRECTED DRAWINGS (as "replacement sheets") mu	ust be submitted.			
(a) I including changes required by the Notice of Draftsper	rson's Patent Drawing Review	v (PTO-948) attached		
1) hereto or 2) to Paper No./Mail Date	_			
(b) including changes required by the attached Examine Paper No./Mail Date	r's Amendment / Comment or	in the Office action of		
Identifying Indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in			ack) of	
 DEPOSIT OF and/or INFORMATION about the dep attached Examiner's comment regarding REQUIREMENT 			e the	
Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5. ☐ Notice of In	formal Patent Application		
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☑ Interview S	ummary (PTO-413), Mail Date 12/01/2009 .		
Information Disclosure Statements (PTO/SB/08), Page No. (Mail Date	7. 🛭 Examiner's	Amendment/Comment		
Paper No./Mail Date	8. 🛭 Examiner's	Statement of Reasons for Allowa	ince	
	9. 🗖 Other	-		
/Binh X Tran/ Primary Examiner, Art Unit 1792				

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DETAILED ACTION

Continued Examination Under 37 CFR 1.114

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 9-29-2009 has been entered.

EXAMINER'S AMENDMENT

- 2. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.
- Authorization for this examiner's amendment was given in a telephone interview with Jon Christensen on 12-01-2009.
- The application has been amended as follows:

In the claims

In line 3 of claim 1, after the term "treating" please delete the term "an".

In the Specification

In page 7 line 18 of the specification please insert the following new paragraph:

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-- Figs 1-7 depict a series of process steps and apparatus associated with those process steps in accordance with an illustrated embodiment of the invention. –

Allowable Subject Matter

- Claims 1-2, 4, 7-13, 16-21 are allowed.
- 6. The following is an examiner's statement of reasons for allowance: Respect to claims 1-2, 4, 7-13, the cited prior arts fail to disclose or suggest the step of treating a restricted area of a pre-shrunk porous hydrophobic substrate wherein said area is less hydrophobic than a surrounding area of said substrate in combination with treating the dried slurry to remove organic materials. Respect to claim 16-19, the cited prior arts fail to disclose or suggest the step of treating the well area to increase the surface energy of the well area by at least 10 to 15 dynes/cm² so that said well area is less hydrophobic than a surrounding area of said PTFE sheet in combination with curing the dried slurry to remove organic material and all other limitation in the claims. Respect to claims 20-21, the cited prior arts fail to disclose or suggest an gas diffusion electrode which has been prepared by providing a pre\- shrunk microporous PTFE substrate with a confined area that is less hydrophobic than a surrounding area of said substrate in combination with heating the slurry and the PTFE substrate in the confined area to dry the slurry.
- 7. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

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Any inquiry concerning this communication or earlier communications from the
examiner should be directed to Binh X. Tran whose telephone number is (571)2721469. The examiner can normally be reached on Monday-Thursday and every other
Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine Norton can be reached on (571) 272-1465. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Binh X Tran Primary Examiner Art Unit 1792

/Binh X Tran/ Primary Examiner, Art Unit 1792